

FORM PTO-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTORNEY DOCKET NUMBER 024808-00014	NEW PATENT APPLICATION
LIST OF REFERENCES CITED BY APPLICANT (Use several sheets if necessary)		APPLICANT Kazunari HONMA, et al.	
		FILING DATE August 1, 2003	GROUP

U.S. PATENT DOCUMENTS

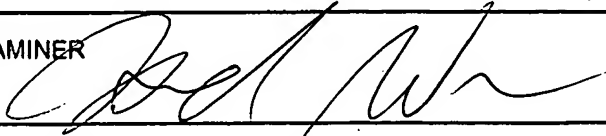
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION YES NO PART.		
	AG	11-068057	March 9, 1999	Japan					X
	AH	2001-072416	March 21, 2001	Japan					X
	AI	11-080181	March 26, 1999	Japan					X
	AJ								
	AK								
	AL								

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

	AM	Item 1 "Low Temperature Deposition Material" Section 4 "New Deposition Material" Ferroelectric Memory Advanced Process September 13, 1999	No trans for concrete Ex planing provided
	AN		
	AO		

EXAMINER 	DATE CONSIDERED 6/8/05
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	